

SPIS Other improvements currently **under developments**

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SPINE meeting Toulouse

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(1) Artenum, (2) ONERA

Shared effort

- ▶ Most of these developments are funded by ESA CNN in the frame of th SPIS Time Dependent evolution
- ▶ Also external contributions
 - ▶ CETP
 - ▶ Artenum's own effort
 - ▶ Improvment of JFreeMesh
 - ▶ Some elements coming from the Keridwen IME (e.g. Kerwizard...)
 - ▶ Cassandra/Cassandra-PCS

Improved / experimental aspect

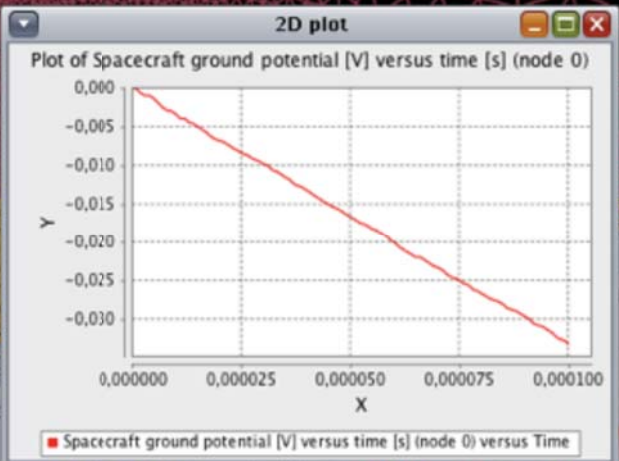
Spacecraft Plasma Interaction System

File Edit GEOM Mesh Properties Groups Fields Solvers PostProcessing Tasks Data Bus Reporting Tools Preferences Help

Pre-Processing Simulation Post-Processing

2D plot

Plot of Spacecraft ground potential [V] versus time [s] (node 0)



Y

X

Collected current [A] versus time [s]: all p...

Show Plots

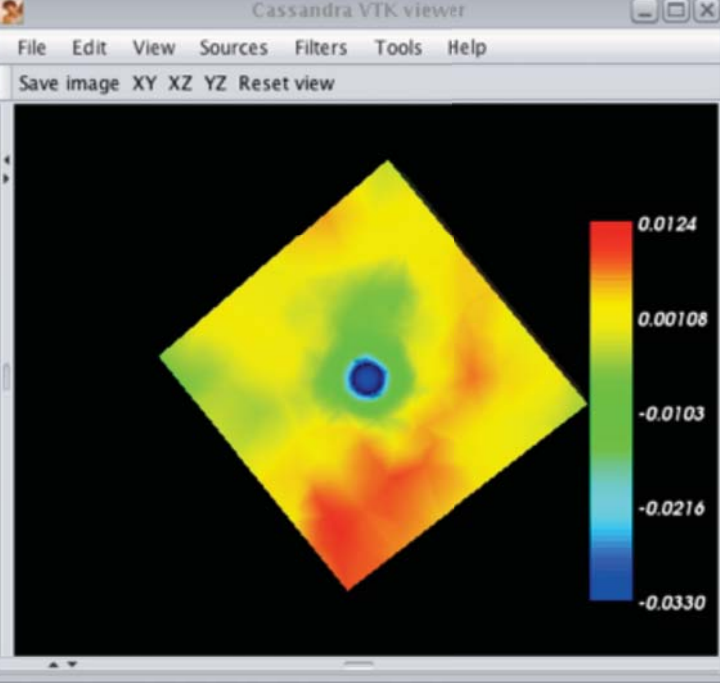
populations,

Collected current [A] versus time [s]: all populations, all nodes, versus Tir

Cassandra VTK viewer

File Edit View Sources Filters Tools Help

Save image XY XZ YZ Reset view



0.0124

0.00108

-0.0103

-0.0216

-0.0330

Jython Log

Standard Log

Console

Done
task CallCassandra just terminate

- INFO [TaskBuildPlot2D] - 2009-09-29 10:47:53,945 Show plot
- INFO [BuildPlot2D] - 2009-09-29 10:47:53,946 Initialisation of the 2D plot logger displaying

Auto scroll

Min Inf

Clear

JyConsole by Artenum, <http://www.artenum.com>
Type "copyright", "credits" or "license" for more information.

>>>

Underdevelopment efforts

▶ Error treatment

- ▶ Improved error and stack trace by the integration of a generic logger
- ▶ Improved “user level/explicit” error messages
- ▶ Development of a “Mesh Inspector” to analyse the mesh consistency.
- ▶ Develop test plan and perform testing

▶ Material parameter input:

- ▶ Re-factoring of data structure for material data in UI
- ▶ Development of an In/Out module to read external files (e.g. NASCAP-2K)
- ▶ Re-factoring of the interface with NUM and internal refactoring in NUM
- ▶ Update/extension of material parameters list
- ▶ Develop test plan and perform testing

▶ Physics improvements

- ▶ Implement emission of multiple species from a single emitter
- ▶ Implement reflection of particles at boundaries
- ▶ Implement neutral particles
- ▶ Develop test plan and perform testing

▶ Simplify the UI for tailored application

- ▶ Wizard based approaches
- ▶ Dedicated tools

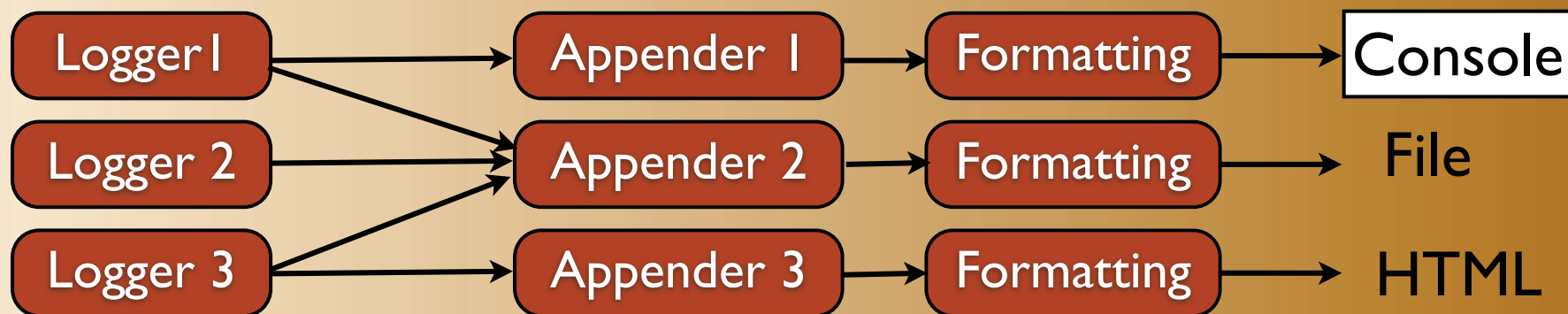
Why an improved logging system ?

▶ Objectives

- ▶ Introduce a normalised logging system, in order to:
 - ▶ Improve the awareness of the user in case of errors and warnings
 - ▶ Facilitate the debugging and the users' feedbacks collection
 - ▶ Detailed and standardised logging files to facilitate the diagnostic
- ▶ Evolutive, in order to extend the level of information for each error in function on the level of expertise accumulated by the community
- ▶ Offer several levels of verbosity
- ▶ Dynamically configurable
- ▶ Use more standard technics, compliant with the several level of languages used in SPIS (Jython, Java, native...)

logging system principle and techno: log4j and SFL4J

- ▶ Use open standards
 - ▶ **Abstract logging API: SFL4J**
 - ▶ Generic and standardised API upper the really implemented logging API
 - ▶ Possibility to change the logging lib without modification of the source code
 - ▶ Used by several major projects
 - ▶ Improved performances and additional features (e.g profiling...)
 - ▶ **Logging and appending concrete implementations: Apache Log4J**
 - ▶ The reference !
 - ▶ Offer several levels of verbosity (debug, info, warning, error...)
 - ▶ Offer a large set of outputs possibilities (console, files, html, etc..)
 - ▶ Offer an extensible framework
- ▶ Both compliant with Jython an Java
- ▶ The whole dynamically configurable



A simple implementation

- ▶ Create loggers in the relevant classes or group of classes

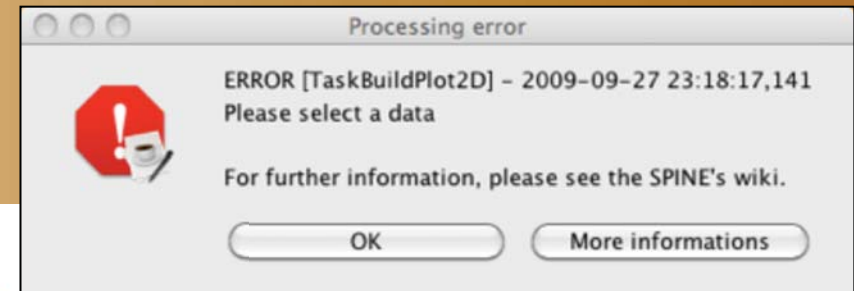
```
# building of the related logger
self.logger = LoggerFactory.getLogger("TaskLoadProj")
self.logger.info("ProjectLoader2 initialised")
```

- ▶ Replace «print» or «System.out.println» by a logging action

```
if "projectInfo" in self.keysList:
    self.logger.info("Loading project's informations")
    try:
        load_dict(sharedProjectInfos, project_file)
        self.logger.info("Done")
    except:
        #print >> sys.stderr, "No project file. Pr
        self.logger.warn("No project file. Probably invalid directory.")
```

- ▶ Configure the link with the appenders (see next slide)
- ▶ Use on of the three man appender/outputs defined
 - ▶ Error dialog box with link to the SPINE platform
 - ▶ Improved logging console
 - ▶ Log file (Saved in the project directory !)

```
✓ INFO [TaskLoadProj] - 2009-09-27 23:15:01,479 Loading groups
🔧 DEBUG [TaskLoadProj] - 2009-09-27 23:15:01,485 loading the new format
🔧 DEBUG [TaskLoadProj] - 2009-09-27 23:15:01,487 loading groupsPriorityList
🔧 DEBUG [TaskLoadProj] - 2009-09-27 23:15:01,508 loading geoGroup56.py
🔧 DEBUG [TaskLoadProj] - 2009-09-27 23:15:01,531 loading geoGroup57.py
⚠ WARN [TaskLoadProj] - 2009-09-27 23:15:01,555 Warning in Material property re-connection
✗ ERROR [TaskBuildPlot2D] - 2009-09-27 23:18:17,141 Please select a data
```



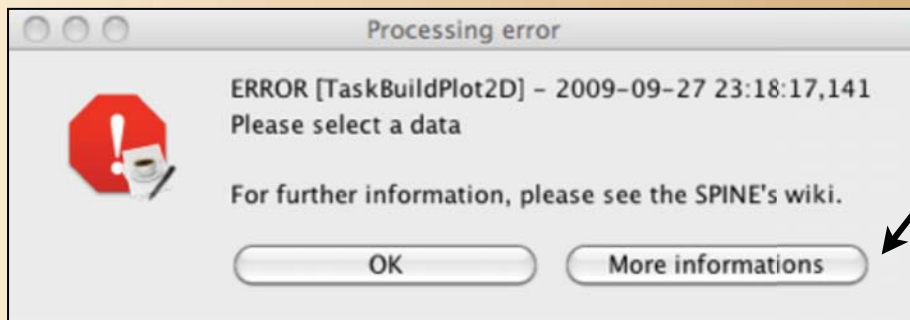
Dynamical configuration

- ▶ Links between loggers and appenders can be defined at the runtime through an XML based file (SPIS_ROOT/SpisUI/AuxLib/GUI/ressources/log4j.xml)
- ▶ Re-read at each restart of the framework. Does not need any re-compilation.
- ▶ Can define:
 - ▶ The output format (data, time, source class or logger...)
 - ▶ The link logger to appender (i.e select the output directions)
 - ▶ The level of verbosity

```
<logger name="TaskLoadProj" additivity="true">  
  <priority value = "warn" />  
  <appender-ref ref="pythonLog" />  
  <appender-ref ref="dialogBox"/>  
  <appender-ref ref="file" />  
</logger>
```


Problematic of definition of a usefull message

- ▶ Most of the error cases in SPIS are due to wrong configurations in amount phases.
- ▶ The reasons can be very variable and are generally not very well identified or, at least, not in a systematic manner and is an evolutive situation that:
 - ▶ Depends on the studied physics and modelled systems
 - ▶ Depends on modelling process
 - ▶ Depends on the «functional module» between the seat and the keyboard
 - ▶ Cannot address all the cases
- ▶ Difficult to give a unique, relevant and general answer (including for the «experts»)
- ▶ To solve this problem, it is proposed to
 - ▶ Use the community
 - ▶ Build-up a system that can be progressively improved
- ▶ Error messages generate a error dialog box, where a Web link is available toward a dedicated forum on the SPINE platform, the *SPINE's Online Help*.



Open the default browser to the SPINE Online Help

<http://dev.spis.org/projects/spine/home/spis/software/onlinehelp/>

Mesh inspector

- ▶ Sub-routine directly integrated into JFreeMesh
 - ▶ Better integration
 - ▶ Better performances
 - ▶ Currently implemented sub-routines / tests
 - ▶ Face/nodes relative position test
 - ▶ Cell/Faces neighbouring test
 - ▶ Quality evaluation (volume/height ratio)
 - ▶ Barycentre...
- ▶ Dedicated GUI still under development and various approaches studied
 - ▶ As standalone module in order simple and «automatic» basic tests
 - ▶ As plug-in in Cassandra in order to
 - ▶ Visualise and identify the corrupted mesh elements
 - ▶ Need to develop the corresponding VTK structure generator

NASCAP material reader/writer

- ▶ Development an import/exporter for NASCAP based format based on SAX
 - ▶ Developed in Java and based on SAX
 - ▶ Integrated into org.spis.imp.io.nascap (i.e lib of main SPIS GUI)
 - ▶ NascapXMLReader
 - ▶ NascapXMLWriter
- ▶ Modification of NascapMaterial as *NascapMaterialFactory* (Modules.Properties)
- ▶ Development of a *NascapMaterialImporter* module (Bin) in Jython + a basic GUI (under development)
- ▶ Extension will probably lead to a format extension/re-definition
- ▶ This is of SPINE normalisation effort

```

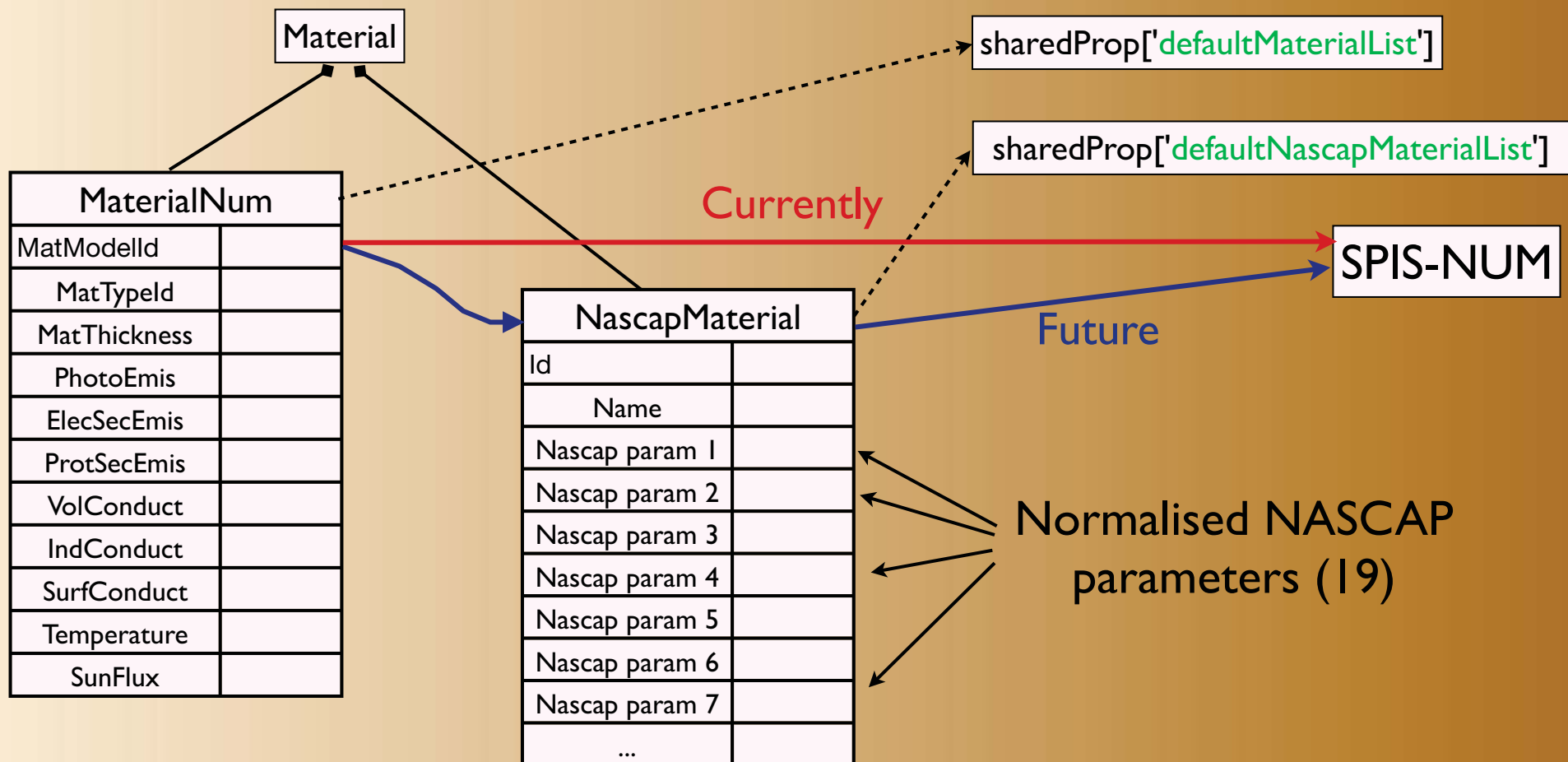
<Assembly>
  <MaterialProperties Name="Aluminum" Color="16776960"
    <Property Index="0" Value="1.0" />
    <Property Index="1" Value="0.0010" />
    <Property Index="2" Value="-1.0" />
    <Property Index="3" Value="13.0" />
    <Property Index="4" Value="0.97" />
    <Property Index="5" Value="0.3" />
    <Property Index="6" Value="154.0" />
    <Property Index="7" Value="0.8" />
    <Property Index="8" Value="220.0" />
    <Property Index="9" Value="1.76" />
    <Property Index="10" Value="0.244" />
    <Property Index="11" Value="230.0" />
    <Property Index="12" Value="4.0E-5" />
    <Property Index="13" Value="-1.0" />
    <Property Index="14" Value="26.98" />
    <Property Index="15" Value="2699.0" />
    <Property Index="16" Value="17.0" />
    <Property Index="17" Value="18.0" />
    <Property Index="18" Value="1.0E-16" />
    <Property Index="19" Value="20.0" />
  </MaterialProperties>

```

- 0: ITOC (Material coated with ITO)
- 1: CERS (Solar cell material. Cerium doped silicon with MgF2 coating)
- 2: CFRP (Carbon fibre, conducting, no resin layer)
- 3: KAPT (Kapton, average values for SEE...)
- 4: COSR (Optical solar reflector without MgF2 coating. Cerium doped glass type)
- 5: EPOX (Epoxy. Thin layer of Epoxy resin on (conducting) Carbon fibre)
- 6: BLKP (Non conductive black paint. SEE yields are as measured for Electrodag 501)
- 7: BLKH (Non conductive black paint HERBERTS 1002-E. Values updated 3.10.88.)
- 8: BLKC (Conductive black paint Electrodag 501)
- 9: PCBZ (White paint PCB-Z assumed to be conductive in space)
- 10: PSG1 (White paint PSG 120 FD assumed to be conductive in space.)
- 11: TEFL (Teflon, DERTS measurements of SEE)
- 12: CONT (Generic Dielectric after 5 years in GEO environment.)
- 13: GOLD
- 14: SILV (Silver as from NASCAP library)
- 15: ALOX (Oxydized Aluminium. SEE yields from DERTS for Aluminium/Kapton)
- 16: STEE (Steel, SEE sigma +E_{max} from DERTS, curve shape from CONT material)
- 17: AL2K (Aluminium according to NASCAP-2k)
- 18: AU2K (Gold according to NASACP-2k)
- 19: KA2K (Kapton according to NASACP-2k))
- 20: TE2K (Teflon according to NASACP-2k)
- 21: OSR2K (OSR according to NASACP-2k)
- 22: BK2K (Black Kapton according to NASACP-2k)
- 23: SC2K (Solar Cells according to NASACP-2k)
- 24: NP2K (Non-conductive paint according to NASACP-2k)
- 25: GP2K (Graphite according to NASACP-2k)

Data structure: current status and evolutions

- ▶ Current structure based on a «composition» of *Materials*.
- ▶ SPIS-UI and SPIS-Num structures close to each other.
- ▶ But still Jython based and not a clean object oriented structure

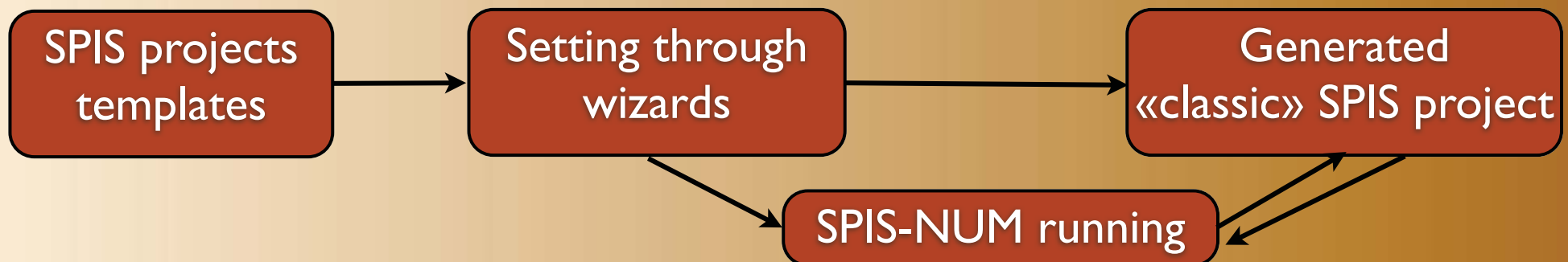
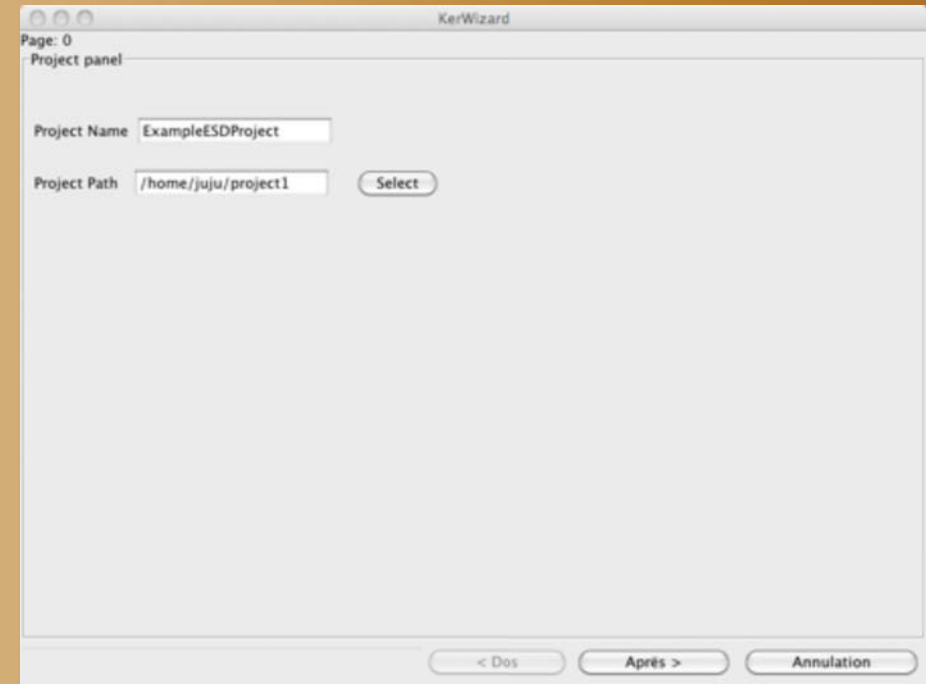


Physics improvements

- ▶ Work mainly on SPIS-NUM side
- ▶ Tasks to be done:
 - ▶ Implementation of multi-species on single emitter
 - ▶ Reflecting for particles
 - ▶ Implementation of neutral particles
 - ▶ Validation and testing

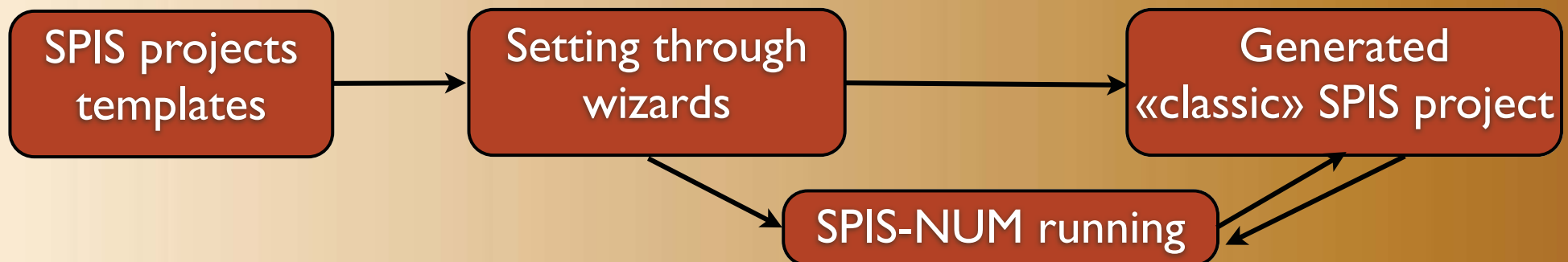
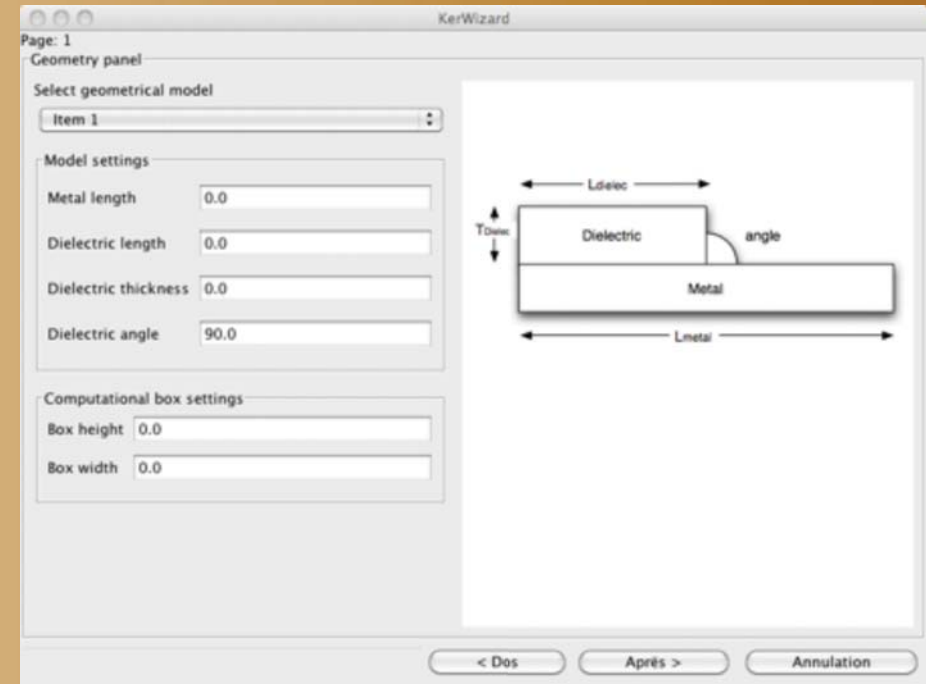
Simplified interfaces for tailored processes

- ▶ Introduction of a wizard based approach
 - ▶ Start from «template project»
 - ▶ Let the access to only «key parameters»
 - ▶ Guide the user step-by-step
 - ▶ Generate a «fully standard» SPIS project, usable as usual.
- ▶ Based on a triple layer architecture
 - ▶ A generic wizard engine (KerWizard), runnable as standalone application or SPIS's task.
 - ▶ A set of tailored panels, that pilots SPIS-UI
 - ▶ SPIS-UI as «piloted model»



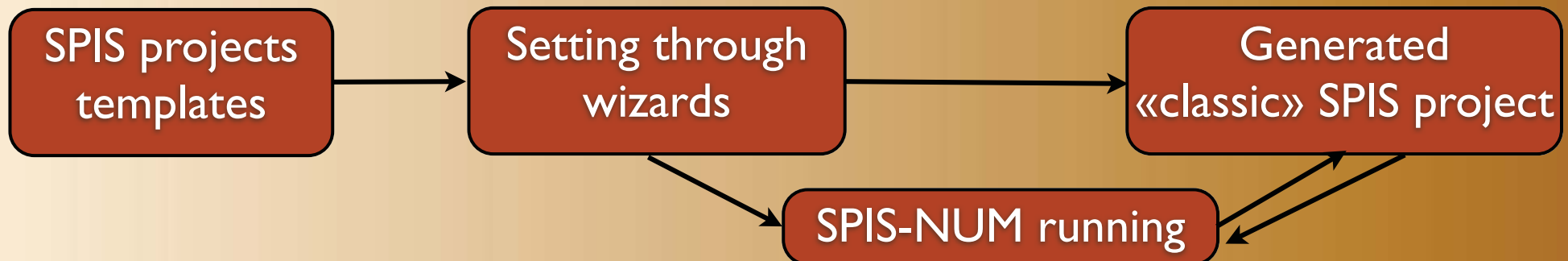
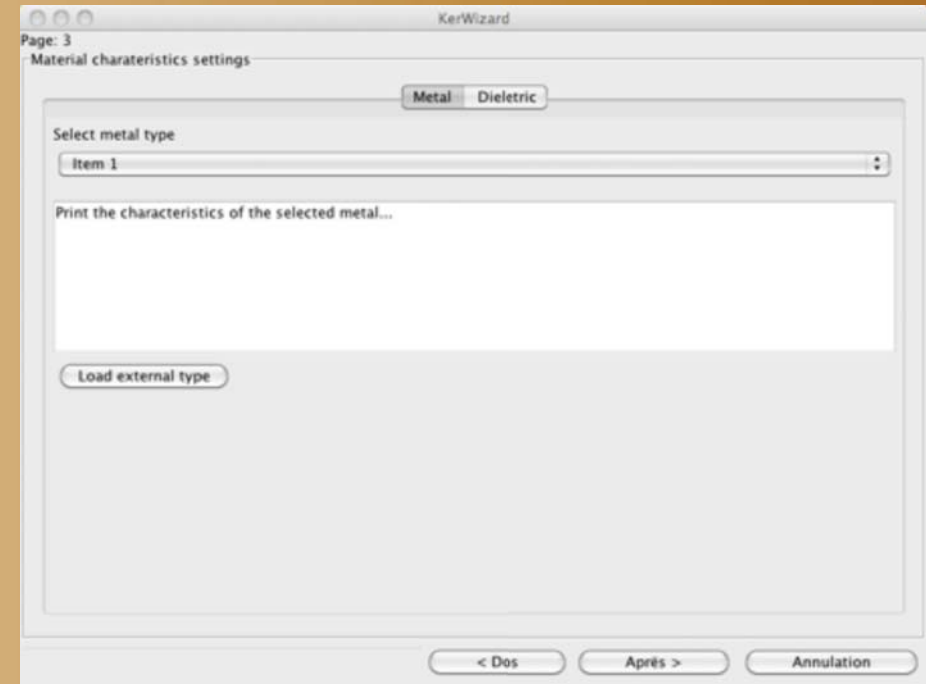
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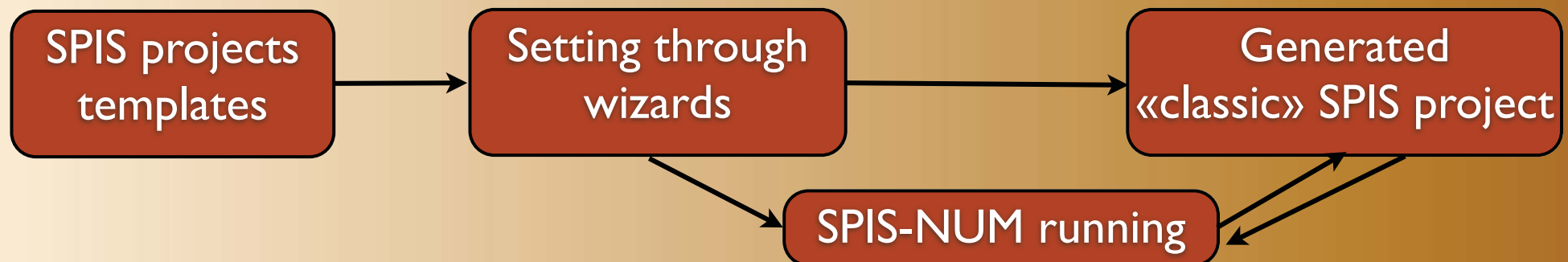
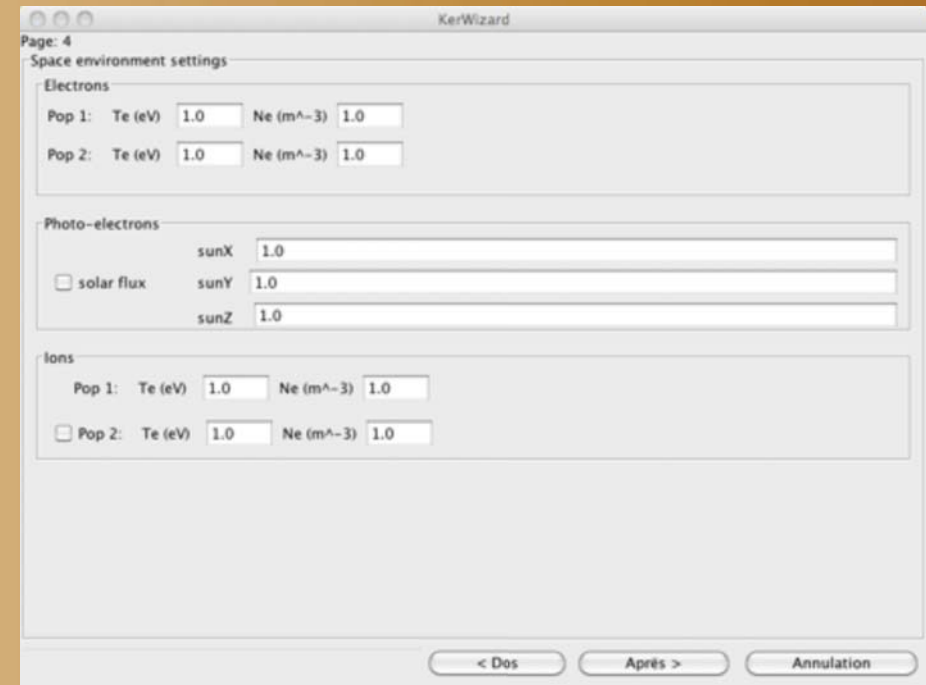
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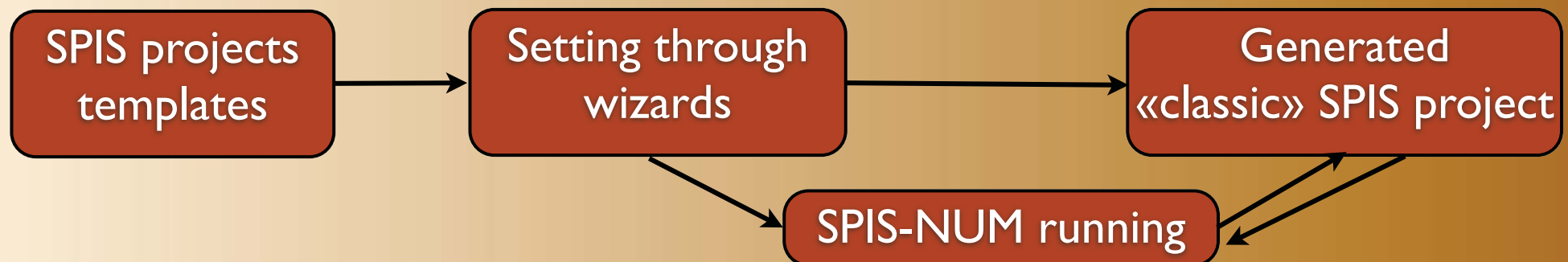
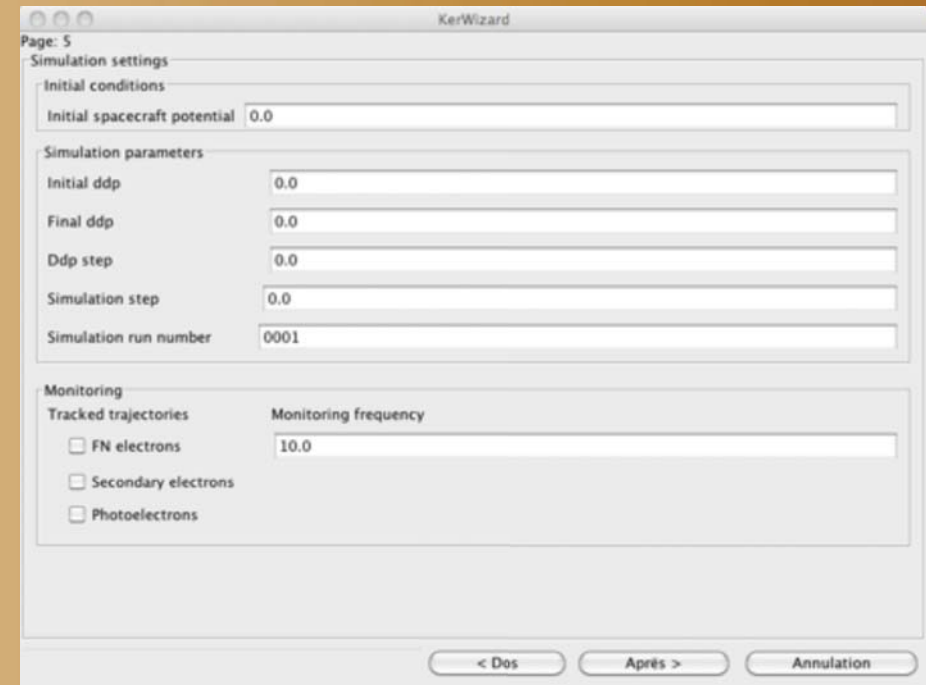
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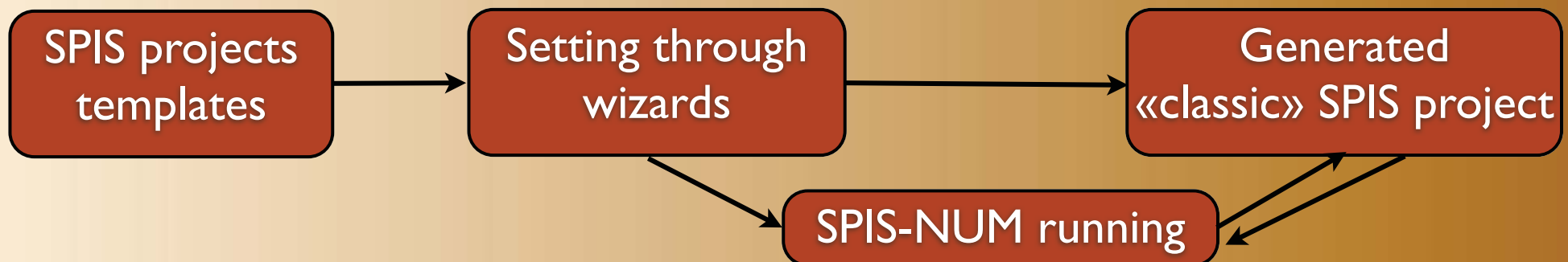
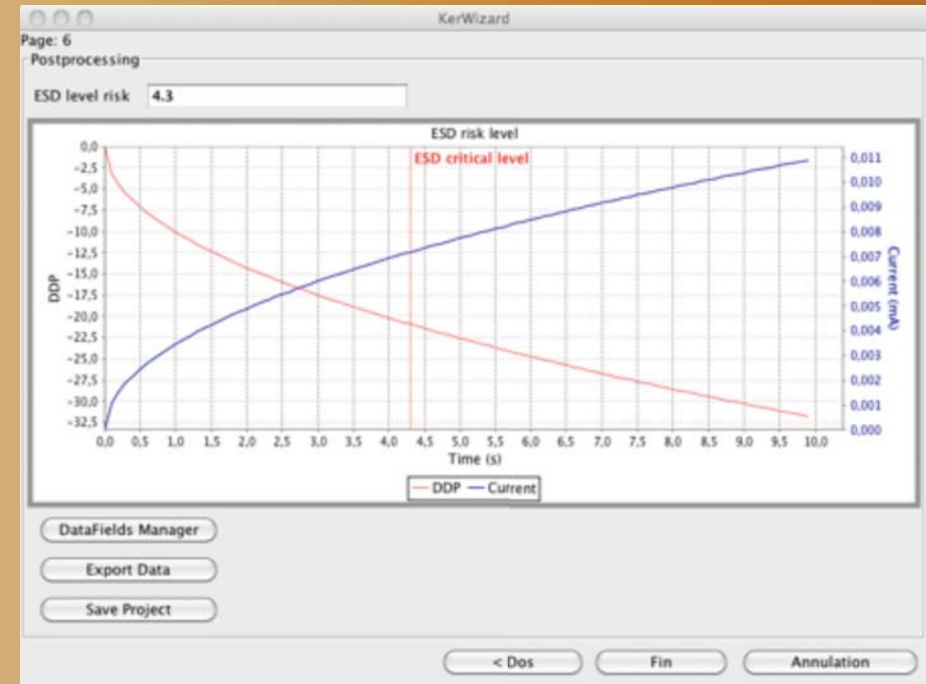
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Conclusion

- ▶ The work must go on.